

THERMAL PROPERTIES OF COPPER TUNGSTEN WITH COPPER VIA COMPOSITE

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October 14, 2011

Presented at the 2011 COMSOL Conference

Introduction

- CuW has been around for a long time
 - ▣ The 1st patent was issued to Paul Schwarzkopf in 1932 (Germany)
 - ▣ As product, CuW has been mature in production for the last 30+ years
- Can we improve CuW's thermal conductivity?
- Can we make a 'SUPER' CuW?

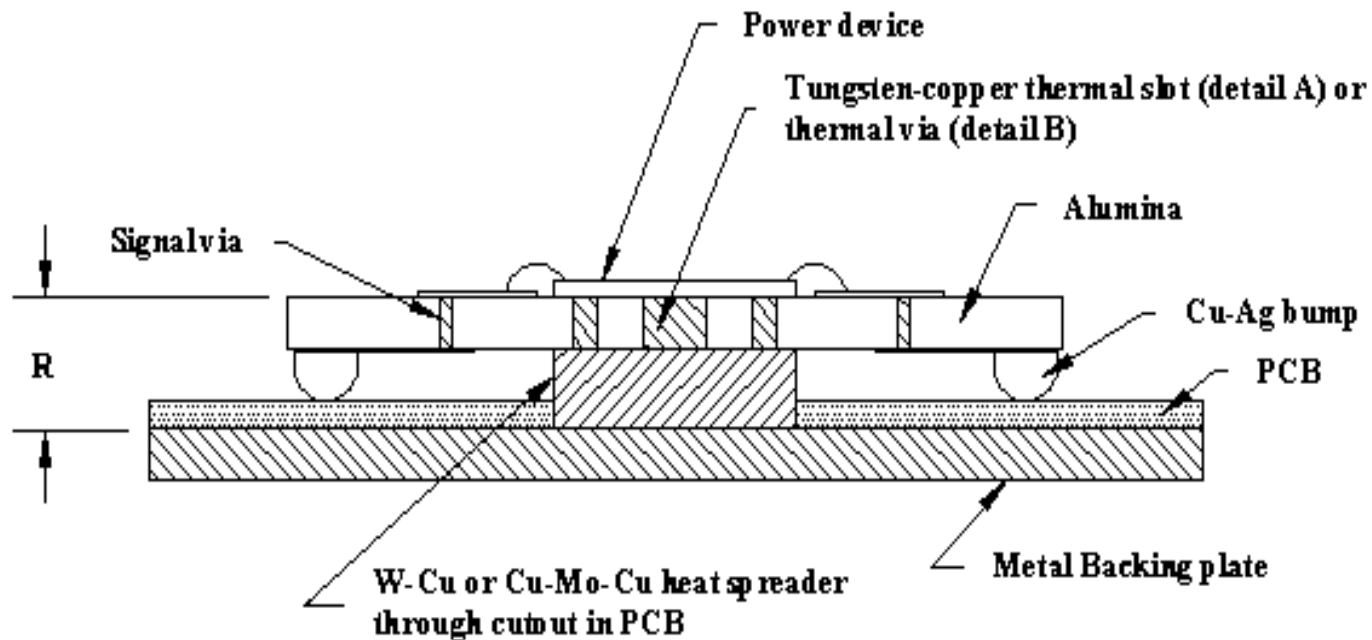
Goal

- To develop a CuW heat sink material that has higher thermal conductivity (TC)
- Control coefficient of thermal expansion (CTE)

Material	CuW	Cu
Thermal Conductivity	175[W/(m*K)]	400[W/(m*K)]
Coefficient of Thermal Expansion	7.57E-6[1/K]	17.0E-6[1/K]

Inspiration

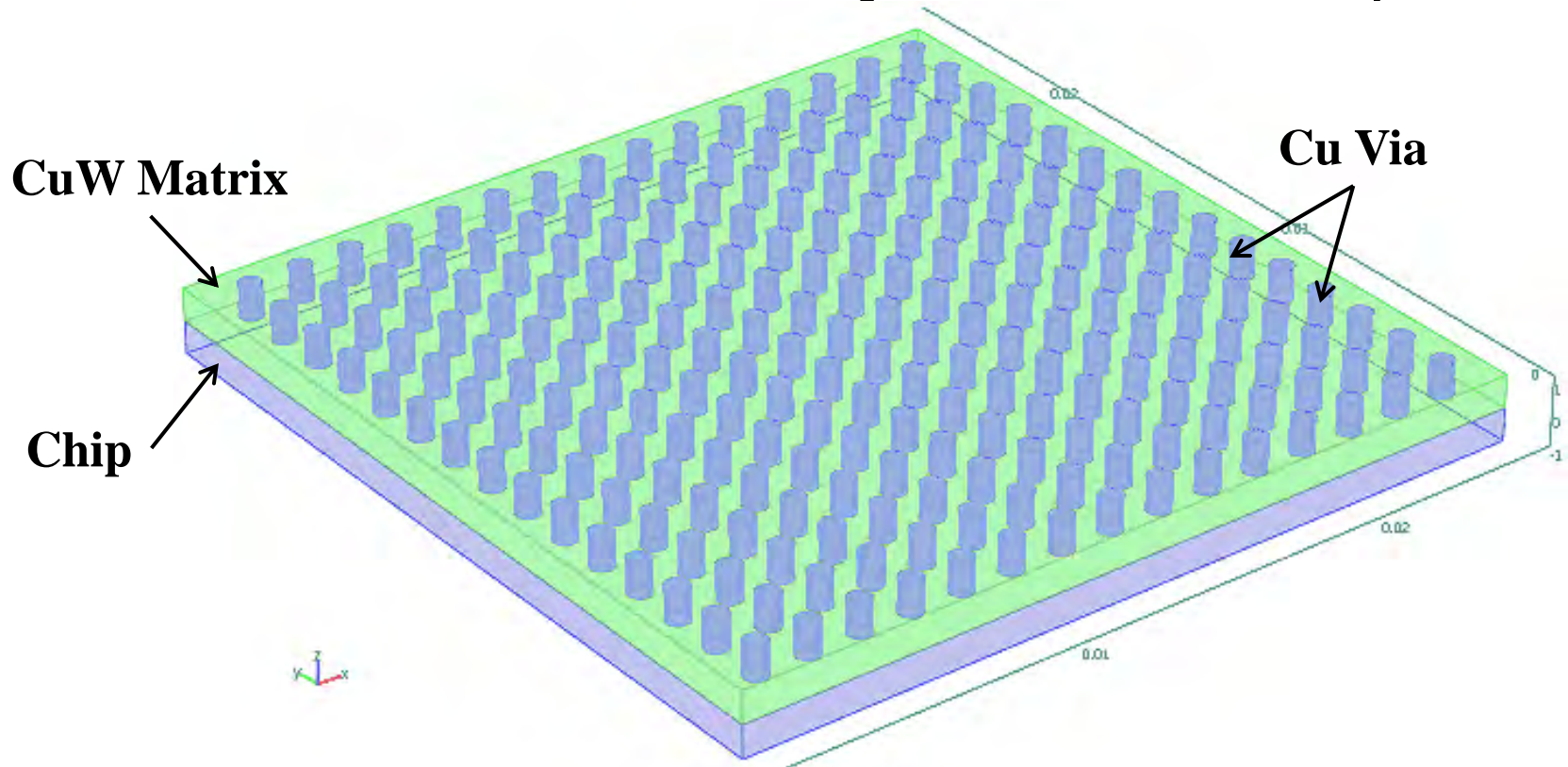
□ Thermal Via



- http://nesl.ee.ucla.edu/courses/ee202a/2003f/submissions/hw2/SEYED_TABATABAEI/images/thermal%20VIABGA%202.gif

Our Approach

- CuW Matrix with an array of Cu Via composite

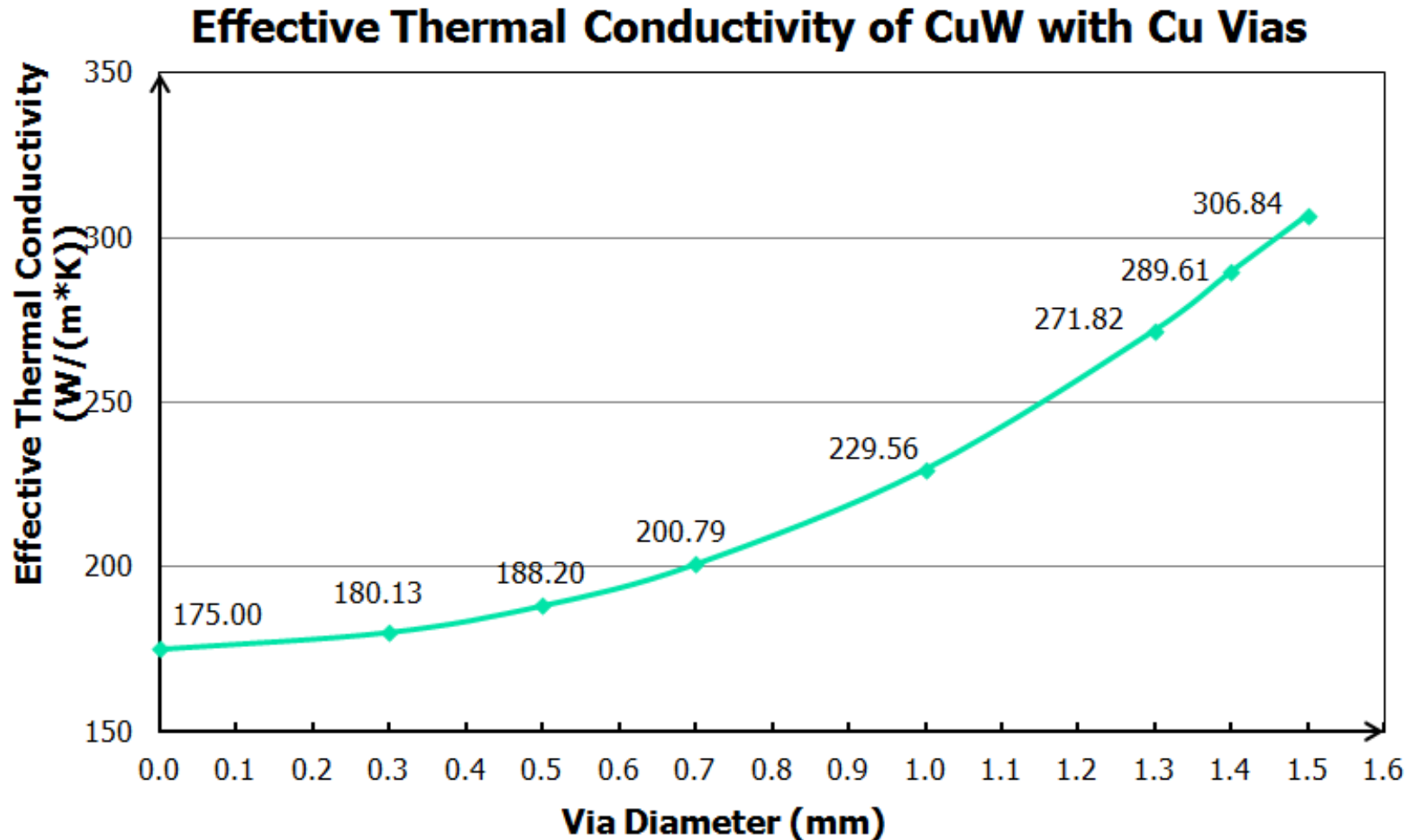


Due to Symmetry, the model can be reduced to a quarter with dimension of 25.0mm X 25.0mm X1.0mm with 25W power as shown below:

COMSOL® Model

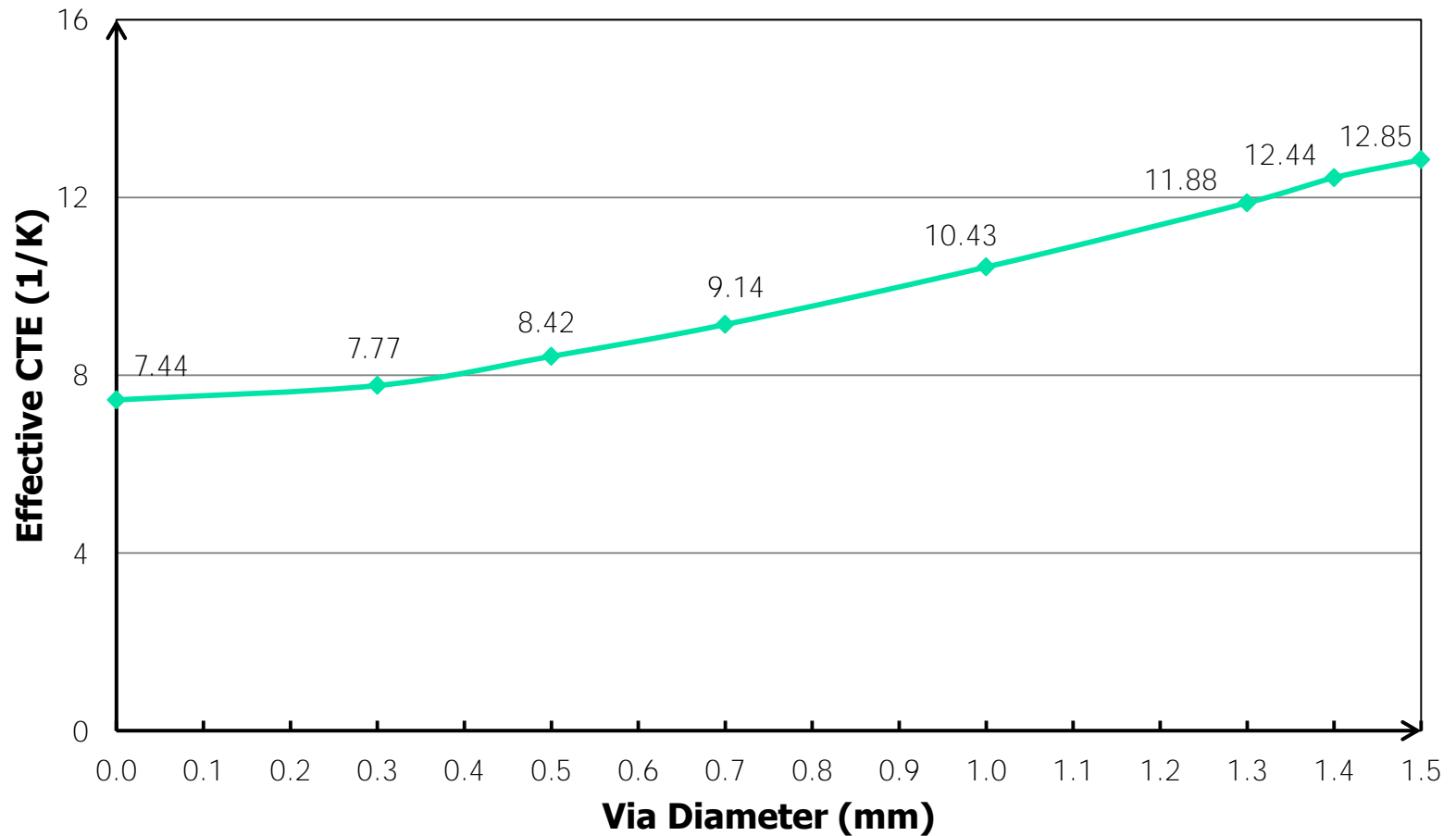
Flange Material	CuW85	Cu
Thermal Conductivity	175 W/(m*K)	400 W/(m*K)
Simulation Environment	COMSOL 3.5a on Windows 7	
Chip Size & Power	Si (50.0mm X 50.0mm X 1.0mm) 100W	
Fixing Method	Bolt Down	
Heat Transfer Coefficient Between Flange & Heat Sink	3000 W/(m²*K)	
Heat Sink Temperature	348.15 K (75 0C)	

Simulated Effective Thermal Conductivity



Simulated Effective CTE

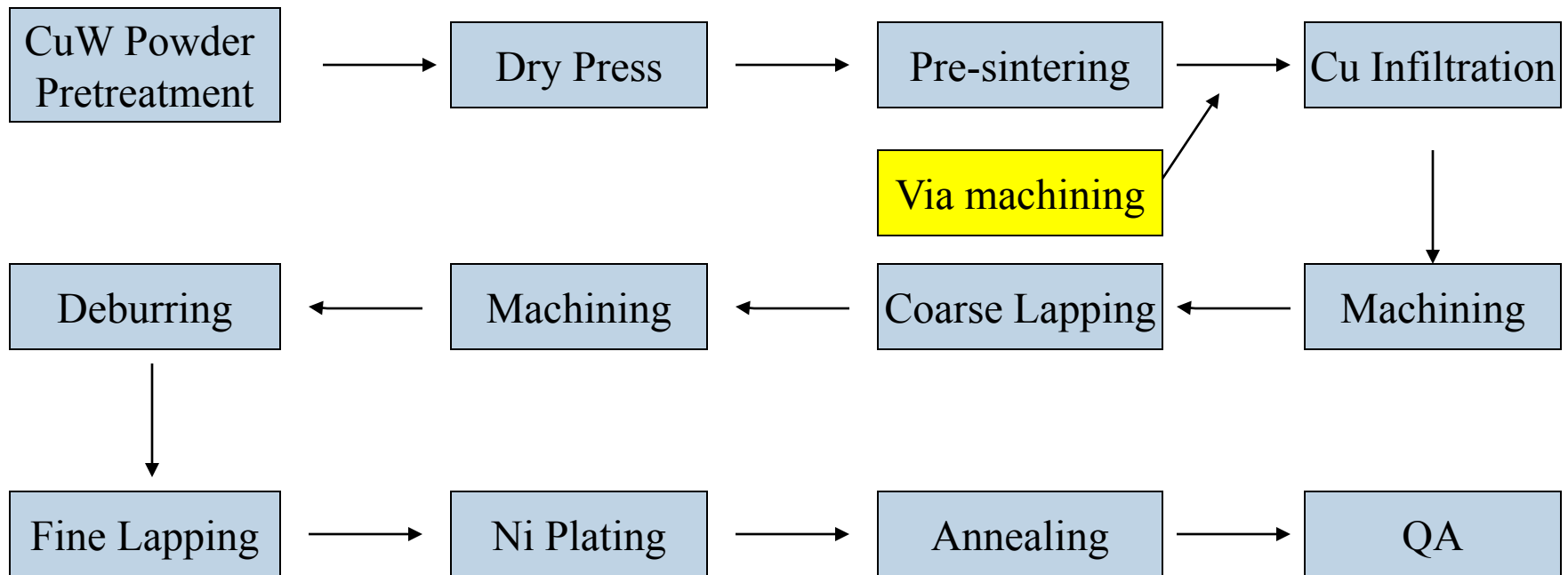
Effective CTE vs. Via Diameter



Experiment

- Sample fabrication was done at the manufacturing facility located in Yixing, China of our industrial partner -Torrey Hill Tech., Inc.
- TC and CTE tests are done by Netzsch Shanghai

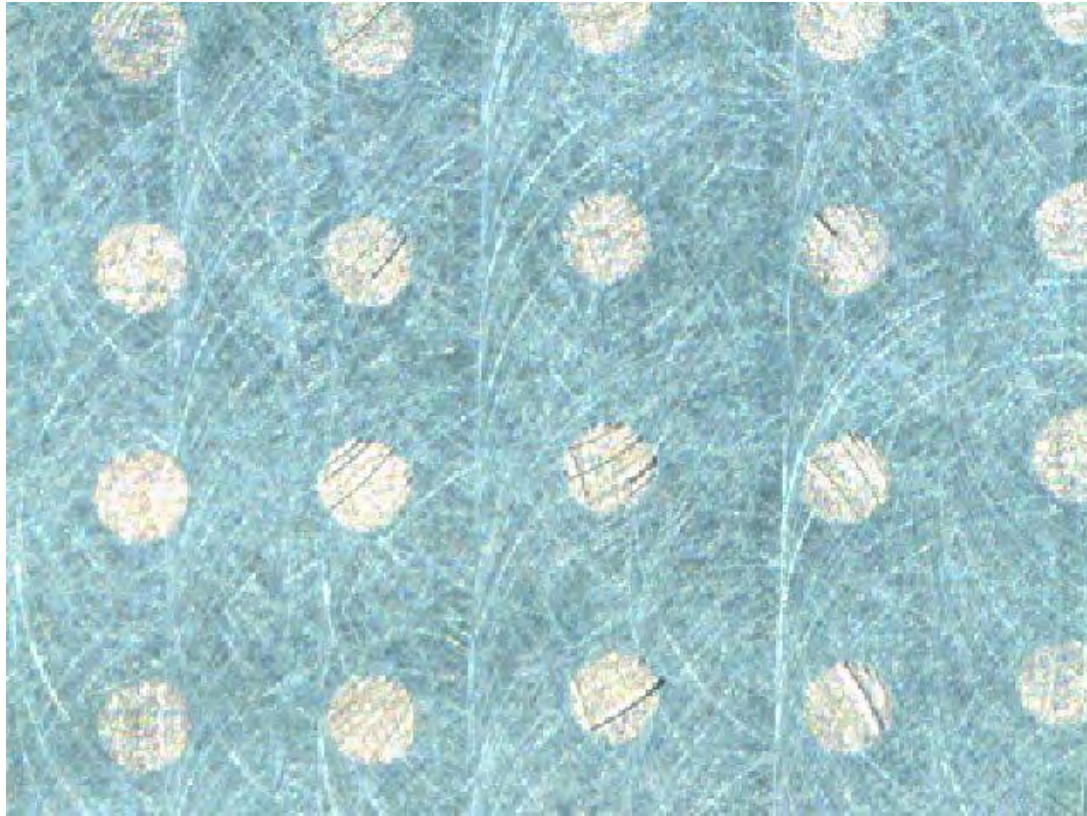
Experiment – Fabrication Process



Equipment for Fabrication



Specimen



CuW with 0.7mm Cu Vias

Results – TC of Pure CuW

热扩散系数 - NETZSCH LFA 分析

常规信息

数据库：	合金.mdb	操作者：	jll
仪器：	LFA 447	备注(测量)：	C0346
标识：	c0346_wcu合金-_2_257o0001 09.09	比热表：	WCu合金-2
日期/时间：	2009-9-14 14:16:52	热膨胀系数表	dL_const
材料：	WCu合金-2	炉体：	NanoFlash 300
密度 (25.0 °C) /(g/cm ³)	16.081	样品支架：	NanoFlash 12.7r
样品：	WCu合金-2	激光：	Xenon NanoFlas
类型：	单层	炉体热电偶：	K
厚度(室温下) /mm：	1.2090	样品热电偶：	K
直径 /mm：	12.730	计算代码：	C+p//0-0-0
检测器：	InSb		

结果

闪射点数	温度 °C	模型	热扩散系数 mm ² /s	导热系数 W/(m·K)	Cp J/g/K	脉冲类型
1	25.0	Cowan 模型 + 脉冲修正	68.244	181.240	0.165	1 (短)
2	25.0	Cowan 模型 + 脉冲修正	67.344	178.849	0.165	1 (短)
3	25.0	Cowan 模型 + 脉冲修正	63.765	169.343	0.165	1 (短)
4	25.0	Cowan 模型 + 脉冲修正	66.778	177.344	0.165	1 (短)
平均值：	25.0		66.533	176.694	0.165	
标准偏差：	0.0		1.942	5.156	0.000	

Results – TC of CuW with 0.7mm Vias

热扩散系数 - NETZSCH LFA 分析

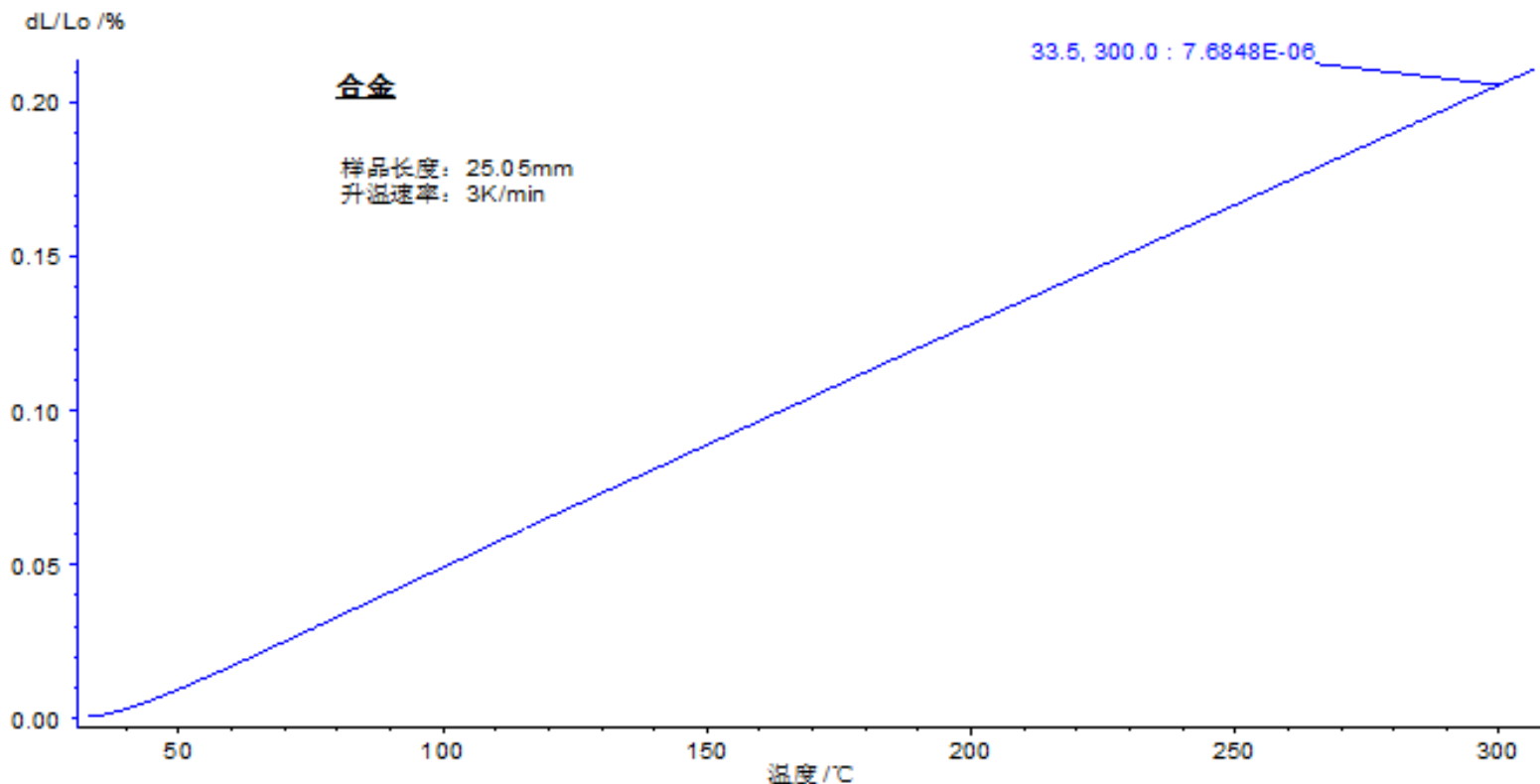
常规信息

数据库：	合金.mdb	操作者：	jll
仪器：	LFA 447	备注(测量)：	C0917
标识：	c0917_合金_3_219n4902 09.08.C	比热表：	合金
日期/时间：	2009-8-7 14:02:43	热膨胀系数表	dL_const
材料：	合金	炉体：	NanoFlash 300
密度 (25.0 °C) /(g/cm ³)	14.899	样品支架：	NanoFlash 10.0sc
样品：	合金	激光：	Xenon NanoFlash
类型：	单层	炉体热电偶：	K
厚度(室温下) /mm：	1.5490	样品热电偶：	K
直径 /mm：	10.000	计算代码：	C+p//0-0-0
检测器：	InSb		

结果

闪射点数	温度 °C	模型	热扩散系数 mm ² /s	导热系数 W/(m*K)	Cp J/g/K	脉冲类型
1	25.0	Cowan 模型 + 脉冲修正	72.880	198.060	0.182	2 (中)
2	25.1	Cowan 模型 + 脉冲修正	73.274	199.131	0.182	2 (中)
3	25.1	Cowan 模型 + 脉冲修正	73.317	199.247	0.182	2 (中)
4	25.1	Cowan 模型 + 脉冲修正	73.981	201.054	0.182	2 (中)
平均值：	25.1		73.363	199.373	0.182	
标准偏差：	0.1		0.457	1.241	0.000	

Results – CTE of CuW with 0.7mm Vias



生成口: 2009-09-16 10:50 用户: NSILab

仪器: NETZSCH DIL 402 PC 文件: D:\DIL402PC\sample0909\江苏高纯合金.d4

项目: C0738
日期时间: 2009-9-15 下午 03:16:15
实验室: NSILAB
操作者: zmf
标识: 合金
样品负载: 合金: 25.050 mm / 30.000 cN

材料: -
气氛: ---
温度校正文件: tcczero.TMX
范围: 33/3.0(Kmin)/310
数: 1/1
模式/测量类型: 标准膨胀计 + 修正

样品列表表: Fused_silica
样品列表材料: FUSED SILICA
校正文件: bt-33-3k-320.d4
标准校正表: Fused_silica
标准校正材料: FUSED SILICA
校正测量范围: 820/5000 um

★.png

Conclusion

- For CuW with 0.7mm Cu Vias, TC is approximately 200 W/mK vs. 175 W/mK for pure CuW, which represents 14% improvement on TC
- CTE of CuW with 0.7mm Cu Vias was measured to be 7.68ppm, which is similar to that of pure CuW 7.57ppm

Future

- CuW with non-uniformly distributed Cu Vias with different size
- CuW/Cu multilayer composite with Cu Vias
- CuW with graphite Vias

Acknowledgement

- Torrey Hills Technologies, LLC.
 - Equipment
 - Furnaces,
 - Electronics packaging
 - SMT
 - Solar cell
 - Other
 - Three roll mills
 - Components
 - CuW, CuMo, W, Mo etc. heat sinks
 - Various metal parts

Questions?

